



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
 Address: COMMISSIONER FOR PATENTS
 P.O. Box 1450
 Alexandria, Virginia 22313-1450
 www.uspto.gov

BIB DATA SHEET

CONFIRMATION NO. 2990

SERIAL NUMBER	FILING or 371(c) DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.		
10/565,767	01/24/2006 RULE	526	1793	OGOSH43USA		
APPLICANTS Yuichiro Shindo, Ibaraki, JAPAN; ** CONTINUING DATA ***** This application is a 371 of PCT/JP04/05389 04/15/2004 ** FOREIGN APPLICATIONS ***** JAPAN 2003-279695 07/25/2003 ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 10/18/2006						
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and Acknowledged <u>/MARK L SHEVIN/</u> Examiner's Signature		<input type="checkbox"/> Met after Allowance <u>/MLS/</u> Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 0	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 2
ADDRESS HOWSON AND HOWSON SUITE 210 501 OFFICE CENTER DRIVE FT WASHINGTON, PA 19034 UNITED STATES						
TITLE Highly pure hafnium material, target thin film comprising the same and method for producing highly pure hafnium						
FILING FEE RECEIVED 900	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit			